

Elzbieta Guziewicz

List of Publications by Year in descending order

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207
papers

3,363
citations

159585

30
h-index

189892

50
g-index

209
all docs

209
docs citations

209
times ranked

3235
citing authors

#	ARTICLE	IF	CITATIONS
1	Extremely low temperature growth of ZnO by atomic layer deposition. Journal of Applied Physics, 2008, 103, .	2.5	223
2	ALD grown zinc oxide with controllable electrical properties. Semiconductor Science and Technology, 2012, 27, 074011.	2.0	134
3	ZnO grown by atomic layer deposition: A material for transparent electronics and organic heterojunctions. Journal of Applied Physics, 2009, 105, .	2.5	114
4	Electrical behavior of zinc oxide layers grown by low temperature atomic layer deposition. Applied Physics Letters, 2008, 92, .	3.3	108
5	Aluminum-doped zinc oxide films grown by atomic layer deposition for transparent electrode applications. Journal of Materials Science: Materials in Electronics, 2011, 22, 1810-1815.	2.2	98
6	Photoemission and the Electronic Structure of PuCoGa ₅ . Physical Review Letters, 2003, 91, 176401.	7.8	94
7	ZnO layers grown by Atomic Layer Deposition: A new material for transparent conductive oxide. Thin Solid Films, 2009, 518, 1145-1148.	1.8	88
8	Controlling of preferential growth mode of ZnO thin films grown by atomic layer deposition. Journal of Crystal Growth, 2008, 310, 284-289.	1.5	78
9	Photoemission of surface oxides and hydrides of delta plutonium. Surface Science, 2004, 571, 74-82.	1.9	76
10	Zinc oxide for electronic, photovoltaic and optoelectronic applications. Low Temperature Physics, 2011, 37, 235-240.	0.6	73
11	Poly(3-hexylthiophene)/ZnO hybrid pn junctions for microelectronics applications. Applied Physics Letters, 2009, 94, .	3.3	71
12	Dispersion in the Mott insulator UO ₂ : A comparison of photoemission spectroscopy and screened hybrid density functional theory. Journal of Computational Chemistry, 2008, 29, 2288-2294.	3.3	65
13	Transparent and conductive undoped zinc oxide thin films grown by atomic layer deposition. Physica Status Solidi (A) Applications and Materials Science, 2010, 207, 1568-1571.	1.8	56
14	Electronic structure of actinide antimonides and tellurides from photoelectron spectroscopy. Physical Review B, 2004, 70, .	3.2	55
15	Structural and optical properties of low-temperature ZnO films grown by atomic layer deposition with diethylzinc and water precursors. Journal of Crystal Growth, 2009, 311, 1096-1101.	1.5	54
16	The influence of growth temperature and precursors' doses on electrical parameters of ZnO thin films grown by atomic layer deposition technique. Microelectronics Journal, 2009, 40, 293-295.	2.0	50
17	Atomic layer deposition grown composite dielectric oxides and ZnO for transparent electronic applications. Thin Solid Films, 2012, 520, 4694-4697.	1.8	46
18	New selector based on zinc oxide grown by low temperature atomic layer deposition for vertically stacked non-volatile memory devices. Microelectronic Engineering, 2008, 85, 2442-2444.	2.4	45

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19	Nonlocal resistance and its fluctuations in microstructures of band-inverted HgTe/(Hg,Cd)Te quantum wells. <i>Physical Review B</i> , 2013, 88, .	3.2	45
20	Photoluminescence, electrical and structural properties of ZnO films, grown by ALD at low temperature. <i>Semiconductor Science and Technology</i> , 2009, 24, 105014.	2.0	43
21	Homogeneous and heterogeneous magnetism in (Zn,Co)O: From a random antiferromagnet to a dipolar superferromagnet by changing the growth temperature. <i>Physical Review B</i> , 2013, 88, .	3.2	43
22	Atomic layer deposition of thin films of ZnSe—structural and optical characterization. <i>Thin Solid Films</i> , 2004, 446, 172-177.	1.8	42
23	ZnO films grown by atomic layer deposition for organic electronics. <i>Semiconductor Science and Technology</i> , 2012, 27, 074006.	2.0	41
24	Angle-resolved photoemission study of USb_2 ’s $5f$ band structure. <i>Physical Review B</i> , 2004, 69, .	3.2	39
25	Magnetic properties of ZnMnO films grown at low temperature by atomic layer deposition. <i>Applied Physics Letters</i> , 2006, 89, 051907.	3.3	38
26	The uniformity of Al distribution in aluminum-doped zinc oxide films grown by atomic layer deposition. <i>Materials Science and Engineering B: Solid-State Materials for Advanced Technology</i> , 2011, 176, 237-241.	3.5	38
27	Vertically stacked non-volatile memory devices — material considerations. <i>Microelectronic Engineering</i> , 2008, 85, 2434-2438.	2.4	37
28	Origin of white color light emission in ALE-grown ZnSe. <i>Journal of Luminescence</i> , 2003, 102-103, 455-459.	3.1	36
29	Monocrystalline zinc oxide films grown by atomic layer deposition. <i>Thin Solid Films</i> , 2010, 518, 4556-4559.	1.8	35
30	Low temperature growth of ZnMnO: A way to avoid inclusions of foreign phases and spinodal decomposition. <i>Applied Physics Letters</i> , 2007, 90, 082502.	3.3	33
31	Abundant Acceptor Emission from Nitrogen-Doped ZnO Films Prepared by Atomic Layer Deposition under Oxygen-Rich Conditions. <i>ACS Applied Materials & Interfaces</i> , 2017, 9, 26143-26150.	8.0	32
32	Optical properties of manganese doped wide band gap ZnS and ZnO. <i>Optical Materials</i> , 2009, 31, 1768-1771.	3.6	30
33	Direct Observation of Itinerant Magnetism in the $5f$ -Electron System UTe. <i>Physical Review Letters</i> , 2004, 93, 267205.	7.8	29
34	ZnTe—ZnO core—shell radial heterostructures grown by the combination of molecular beam epitaxy and atomic layer deposition. <i>Nanotechnology</i> , 2010, 21, 015302.	2.6	28
35	Highly efficient SERS-based detection of cerebrospinal fluid neopterin as a diagnostic marker of bacterial infection. <i>Analytical and Bioanalytical Chemistry</i> , 2016, 408, 4319-4327.	3.7	28
36	Nitrogen doped p -type ZnO films and p - n homojunction. <i>Semiconductor Science and Technology</i> , 2015, 30, 015001.	2.0	27

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37	Al ₂ O ₃ /HfO ₂ Multilayer High-κ Dielectric Stacks for Charge Trapping Flash Memories. <i>Physica Status Solidi (A) Applications and Materials Science</i> , 2018, 215, 1700854.	1.8	27
38	Hafnium dioxide as a passivating layer and diffusive barrier in ZnO/Ag Schottky junctions obtained by atomic layer deposition. <i>Applied Physics Letters</i> , 2011, 98, .	3.3	26
39	Photovoltaic cells based on nickel phthalocyanine and zinc oxide formed by atomic layer deposition. <i>Central European Journal of Physics</i> , 2010, 8, 798-803.	0.3	25
40	The properties of tris (8-hydroxyquinoline) aluminum organic light emitting diode with undoped zinc oxide anode layer. <i>Journal of Applied Physics</i> , 2010, 108, 064518.	2.5	25
41	XPS study of arsenic doped ZnO grown by Atomic Layer Deposition. <i>Journal of Alloys and Compounds</i> , 2014, 582, 594-597.	5.5	25
42	Extra-Low Temperature Growth of ZnO by Atomic Layer Deposition with Diethylzinc Precursor. <i>Acta Physica Polonica A</i> , 2007, 112, 401-406.	0.5	25
43	Properties and Characterization of ALD Grown Dielectric Oxides for MIS Structures. <i>Acta Physica Polonica A</i> , 2011, 119, 692-695.	0.5	25
44	The photoluminescence response to structural changes of Yb implanted ZnO crystals subjected to non-equilibrium processing. <i>Journal of Applied Physics</i> , 2017, 121, .	2.5	23
45	ZnO, ZnMnO and ZnCoO films grown by atomic layer deposition. <i>Semiconductor Science and Technology</i> , 2012, 27, 074009.	2.0	22
46	Influence of oxygen-rich and zinc-rich conditions on donor and acceptor states and conductivity mechanism of ZnO films grown by ALD—Experimental studies. <i>Journal of Applied Physics</i> , 2020, 127, .	2.5	22
47	Observation of a kink in the dispersion of f-electrons. <i>Europhysics Letters</i> , 2008, 84, 37003.	2.0	21
48	Zinc Oxide Grown by Atomic Layer Deposition: From Heavily n-type to p-type Material. <i>Physica Status Solidi (B): Basic Research</i> , 2020, 257, 1900472.	1.5	21
49	Growth by atomic layer epitaxy and characterization of thin films of ZnO. <i>Physica Status Solidi C: Current Topics in Solid State Physics</i> , 2005, 2, 1125-1130.	0.8	20
50	Dual nature of the 5f electrons in plutonium materials. <i>Physica B: Condensed Matter</i> , 2006, 378-380, 920-924.	2.7	20
51	Dominant shallow donors in zinc oxide layers obtained by low-temperature atomic layer deposition: Electrical and optical investigations. <i>Acta Materialia</i> , 2014, 65, 69-75.	7.9	20
52	Diversity of contributions leading to the nominally n-type behavior of ZnO films obtained by low temperature Atomic Layer Deposition. <i>Journal of Alloys and Compounds</i> , 2017, 727, 902-911.	5.5	19
53	Structural Properties of Thin ZnO Films Deposited by ALD under O-Rich and Zn-Rich Growth Conditions and Their Relationship with Electrical Parameters. <i>Materials</i> , 2021, 14, 4048.	2.9	19
54	ZnO by ALD - Advantages of the Material Grown at Low Temperature. <i>Acta Physica Polonica A</i> , 2009, 116, 814-817.	0.5	19

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55	Thin Films of High- κ Oxides and ZnO for Transparent Electronic Devices. <i>Chemical Vapor Deposition</i> , 2013, 19, 213-220.	1.3	18
56	Hole and electron trapping in HfO ₂ /Al ₂ O ₃ nanolaminated stacks for emerging non-volatile flash memories. <i>Nanotechnology</i> , 2018, 29, 505206.	2.6	18
57	A comparison of hybrid density functional theory with photoemission of surface oxides of $\hat{\nu}$ -plutonium. <i>Surface Science</i> , 2006, 600, 1637-1640.	1.9	17
58	Zinc oxide grown by atomic layer deposition - a material for novel 3D electronics. <i>Physica Status Solidi (B): Basic Research</i> , 2010, 247, 1611-1615.	1.5	17
59	Hybrid Organic/ZnO p-n Junctions with n-Type ZnO Grown by Atomic Layer Deposition. <i>Acta Physica Polonica A</i> , 2008, 114, 1229-1234.	0.5	17
60	Color tuning of white light emission from thin films of ZnSe. <i>Journal of Luminescence</i> , 2007, 125, 85-91.	3.1	16
61	Atomic layer deposited ZnO films implanted with Yb: The influence of Yb location on optical and electrical properties. <i>Thin Solid Films</i> , 2017, 643, 7-15.	1.8	16
62	Application of deposited by ALD HfO ₂ and Al ₂ O ₃ layers in double-gate dielectric stacks for non-volatile semiconductor memory (NVSM) devices. <i>Applied Surface Science</i> , 2012, 258, 8366-8370.	6.1	15
63	Characterization of ZnO Films Grown at Low Temperature. <i>Acta Physica Polonica A</i> , 2008, 114, 1303-1310.	0.5	15
64	Effects related to deposition temperature of ZnCoO films grown by atomic layer deposition - uniformity of Co distribution, structural, optical, electrical and magnetic properties. <i>Physica Status Solidi (B): Basic Research</i> , 2010, 247, 1666-1670.	1.5	14
65	Electrical parameters of ZnO films and ZnO-based junctions obtained by atomic layer deposition. <i>Semiconductor Science and Technology</i> , 2011, 26, 085013.	2.0	14
66	Comparison of dimethylzinc and diethylzinc as precursors for monocrystalline zinc oxide grown by atomic layer deposition method. <i>Physica Status Solidi (B): Basic Research</i> , 2010, 247, 1699-1701.	1.5	13
67	Electronic structure of single crystal UPd ₃ , UGe ₂ , and USb ₂ from hard X-ray and angle-resolved photoelectron spectroscopy. <i>Journal of Electron Spectroscopy and Related Phenomena</i> , 2011, 184, 517-524.	1.7	13
68	n -ZnO/ p -4H-SiC diode: Structural, electrical, and photoresponse characteristics. <i>Applied Physics Letters</i> , 2015, 107, .	3.3	13
69	Photoluminescence investigation of the carrier recombination processes in N-doped and undoped ZnO ALD films grown at low temperature. <i>Journal of Luminescence</i> , 2018, 198, 68-76.	3.1	13
70	Puzzling magneto-optical properties of ZnMnO films. <i>Optical Materials</i> , 2010, 32, 680-684.	3.6	12
71	Role of interface in ferromagnetism of (Zn,Co)O films. <i>Physica Status Solidi (B): Basic Research</i> , 2011, 248, 1596-1600.	1.5	12
72	Atomic layer deposition of Zn _{1-x} Mg _x O:Al transparent conducting films. <i>Journal of Materials Science</i> , 2014, 49, 1512-1518.	3.7	12

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73	ZnO oxide films for ultrasensitive, rapid, and label-free detection of neopterin by surface-enhanced Raman spectroscopy. <i>Analyst</i> , 2015, 140, 5090-5098.	3.5	12
74	Monocrystalline thin films of ZnSe and ZnO grown by atomic layer epitaxy. <i>Vacuum</i> , 2004, 74, 269-272.	3.5	11
75	Electrical characteristics of multilayered HfO ₂ -Al ₂ O ₃ charge trapping stacks deposited by ALD. <i>Journal of Physics: Conference Series</i> , 2016, 764, 012016.	0.4	11
76	Structural and optical studies of Pr implanted ZnO films subjected to a long-time or ultra-fast thermal annealing. <i>Thin Solid Films</i> , 2017, 643, 24-30.	1.8	11
77	Luminescence in the Visible Region from Annealed Thin ALD ZnO Films Implanted with Different Rare Earth Ions. <i>Physica Status Solidi (A) Applications and Materials Science</i> , 2018, 215, 1700889.	1.8	11
78	Rare earth 4f states in AlV _{1-x} RE _x BVI diluted magnetic semiconductors. <i>Journal of Alloys and Compounds</i> , 1999, 286, 121-127.	5.5	10
79	Selected optical properties of core/shell ZnMnTe/ZnO nanowire structures. <i>Physica Status Solidi (B): Basic Research</i> , 2011, 248, 1592-1595.	1.5	10
80	Analysis of scattering mechanisms in zinc oxide films grown by the atomic layer deposition technique. <i>Journal of Applied Physics</i> , 2015, 118, 035706.	2.5	10
81	Stopping and straggling of H and He in ZnO. <i>European Physical Journal D</i> , 2016, 70, 1.	1.3	10
82	Correlations between the structural transformations and concentration quenching effect for RE-implanted ZnO systems. <i>Applied Surface Science</i> , 2020, 521, 146421.	6.1	10
83	Interaction between Sm and GaN—a photoemission study. <i>Surface Science</i> , 2004, 551, 132-142.	1.9	9
84	Electronic structure of layered uranium compounds from photoemission spectroscopy. <i>Surface Science</i> , 2006, 600, 1632-1636.	1.9	9
85	Unusual quasiparticle renormalizations from angle resolved photoemission on USb ₂ . <i>Philosophical Magazine</i> , 2009, 89, 1893-1911.	1.6	9
86	Long time stability of ITO/NiPc/ZnO/Al devices with ZnO buffer layer formed by atomic layer deposition technique—impedance spectroscopy analysis. <i>Materials Science and Engineering B: Solid-State Materials for Advanced Technology</i> , 2010, 172, 272-275.	3.5	9
87	Trap levels in the atomic layer deposition-ZnO/GaN heterojunction—Thermal admittance spectroscopy studies. <i>Journal of Applied Physics</i> , 2013, 113, .	2.5	9
88	The p-ZnO:N-i-Al ₂ O ₃ /n-GaN heterostructure—electron beam induced profiling, electrical properties and UV detectivity. <i>Journal Physics D: Applied Physics</i> , 2015, 48, 325105.	2.8	9
89	N and Al co-doping as a way to p-type ZnO without post-growth annealing. <i>Materials Research Express</i> , 2016, 3, 125907.	1.6	9
90	The chemical states of As 3d in highly doped ZnO grown by Molecular Beam Epitaxy and annealed in different atmospheres. <i>Thin Solid Films</i> , 2016, 605, 283-288.	1.8	9

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91	Resonant Photoemission Spectroscopy Study on the Contribution of the Yb 4f States to the Electronic Structure of ZnO. <i>Acta Physica Polonica A</i> , 2018, 133, 907-909.	0.5	9
92	Clean and doped surface electronic structure in angle-resolved and resonant photoemission study. <i>Progress in Surface Science</i> , 2001, 67, 323-338.	8.3	8
93	Enhanced energy pumping to Tb ³⁺ ions in manganese-doped ZnS nanoparticles. <i>Journal of Alloys and Compounds</i> , 2008, 451, 206-208.	5.5	8
94	Contactless electroreflectance of ZnO layers grown by atomic layer deposition at low temperature. <i>Semiconductor Science and Technology</i> , 2011, 26, 075012.	2.0	8
95	Optical Properties of ZnO Deposited by Atomic Layer Deposition on Sapphire: A Comparison of Thin and Thick Films. <i>Physica Status Solidi (A) Applications and Materials Science</i> , 2021, 218, 2000669.	1.8	8
96	Radiation Tolerance and Charge Trapping Enhancement of ALD HfO ₂ /Al ₂ O ₃ Nanolaminated Dielectrics. <i>Materials</i> , 2021, 14, 849.	2.9	8
97	Schottky Junctions Based on the ALD-ZnO Thin Films for Electronic Applications. <i>Acta Physica Polonica A</i> , 2011, 120, A-17-A-21.	0.5	8
98	Epitaxial ZnO Films Grown at Low Temperature for Novel Electronic Application. <i>Acta Physica Polonica A</i> , 2011, 120, A-7-A-10.	0.5	8
99	Photoemission study of Gd atoms on CdTe(100) surface. <i>Applied Surface Science</i> , 2000, 166, 231-236.	6.1	7
100	Photoemission study of Gd on clean Si(1) surface. <i>Surface Science</i> , 2002, 507-510, 218-222.	1.9	7
101	Photoemission study of EuS/PbS electronic structure. <i>Journal of Alloys and Compounds</i> , 2004, 362, 198-201.	5.5	7
102	ZnO nanostructures by atomic layer deposition method. <i>Journal of Physics: Conference Series</i> , 2009, 146, 012017.	0.4	7
103	SEM, EDS and CL Investigations of ZnMnO and ZnCoO Layers Grown at Low Temperature by Atomic Layer Deposition. <i>Microscopy and Microanalysis</i> , 2010, 16, 810-811.	0.4	7
104	Ion Beam Modification of ZnO Epilayers: Sequential Processing. <i>Physica Status Solidi (A) Applications and Materials Science</i> , 2018, 215, 1700887.	1.8	7
105	Do We Understand Magnetic Properties of ZnMnO?. <i>Acta Physica Polonica A</i> , 2007, 112, 261-267.	0.5	7
106	Thin Film ZnO as Sublayer for Electric Contact for Bulk GaN with Low Electron Concentration. <i>Acta Physica Polonica A</i> , 2011, 119, 672-674.	0.5	7
107	Band structure of MBE-grown and photoemission studies. <i>Thin Solid Films</i> , 1995, 267, 69-73.	1.8	6
108	The influence of the Fe 3d states on the electronic band structure of CdTe/Fe and bulk Cd _{0.985} Fe _{0.015} Te crystal. <i>Journal of Alloys and Compounds</i> , 1999, 286, 137-142.	5.5	6

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109	Angle-resolved photoemission study of dispersive and narrow-band 5f states in UAsSe. <i>Physical Review B</i> , 2006, 73, .	3.2	6
110	2-D Finite-Element Modeling of ZnO Schottky Diodes With Large Ideality Factors. <i>IEEE Transactions on Electron Devices</i> , 2012, 59, 2762-2766.	3.0	6
111	Gd and Sm on clean semiconductor surfaces – Resonant photoemission studies. <i>Applied Surface Science</i> , 2013, 282, 326-334.	6.1	6
112	Magnetic, Structural, and Optical Properties of Low Temperature ZnMnO Grown by Atomic Layer Epitaxy. <i>Acta Physica Polonica A</i> , 2005, 108, 915-921.	0.5	6
113	ZnCoO Films Obtained at Low Temperature by Atomic Layer Deposition Using Organic Zinc and Cobalt Precursors. <i>Acta Physica Polonica A</i> , 2008, 114, 1235-1240.	0.5	6
114	ZnCoO Films by Atomic Layer Deposition - Influence of a Growth Temperature on Uniformity of Cobalt Distribution. <i>Acta Physica Polonica A</i> , 2009, 116, 921-923.	0.5	6
115	Barriers in Miniaturization of Electronic Devices and the Ways to Overcome Them - from a Planar to 3D Device Architecture. <i>Acta Physica Polonica A</i> , 2009, 116, S-19-S-21.	0.5	6
116	Electrical properties of ZnO films implanted with rare earth and their relationship with structural and optical parameters. <i>Materials Science and Engineering B: Solid-State Materials for Advanced Technology</i> , 2022, 275, 115526.	3.5	6
117	Resonant photoemission study of rare earth 4f states in $\text{Sn}_{1-x}\text{Gd}_x\text{Te}$. <i>Journal of Electron Spectroscopy and Related Phenomena</i> , 1998, 88-91, 327-331.	1.7	5
118	Photoemission study of Sm/CdTe interface formation. <i>Surface Science</i> , 2001, 482-485, 512-518.	1.9	5
119	Mn on the Surface of ZnO: A Resonant Photoemission Study. <i>Physica Scripta</i> , 2005, , 541.	2.5	5
120	Characterization of n-ZnO/p-GaN Heterojunction for Optoelectronic Applications. <i>Acta Physica Polonica A</i> , 2013, 124, 869-872.	0.5	5
121	Role of the Hafnium Dioxide Spacer in the ZnO-Based Planar Schottky Diodes Obtained by the Low-Temperature Atomic Layer Deposition Method: Investigations of Current-Voltage Characteristics. <i>IEEE Transactions on Electron Devices</i> , 2015, 62, 630-633.	3.0	5
122	Soft x-ray absorption spectroscopy on Co doped ZnO: structural distortions and electronic structure. <i>Journal of Physics: Conference Series</i> , 2016, 712, 012104.	0.4	5
123	Hydrogen in As-Grown and Annealed ZnO Films Grown by Atomic Layer Deposition. <i>Physica Status Solidi (A) Applications and Materials Science</i> , 2021, 218, 2000318.	1.8	5
124	Optical Properties of ZnCoO Films and Nanopowders. <i>Acta Physica Polonica A</i> , 2009, 116, 918-920.	0.5	5
125	Resonant Photoemission Spectra of $\text{Zn}_{1-x}\text{Co}_x\text{S}$ Valence Band. <i>Acta Physica Polonica A</i> , 1994, 86, 831-836.	0.5	5
126	Optical transitions in cubic HgSe crystals. <i>Physical Review B</i> , 1997, 55, 4405-4410.	3.2	4

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127	Optical and photoemission study of surface electronic states and surface oxidation on CdTe(110). Applied Surface Science, 1999, 142, 33-37.	6.1	4
128	Optical and Structural Properties of Thin Films of ZnS Grown by Atomic Layer Epitaxy. Journal of Wide Bandgap Materials, 2001, 9, 55-63.	0.1	4
129	Electrical and optical properties of zinc oxide layers grown by the low-temperature atomic layer deposition technique. Physica Status Solidi (B): Basic Research, 2010, 247, 1653-1657.	1.5	4
130	Optical and magnetic properties of ZnCoO layers. Optical Materials, 2012, 34, 2045-2049.	3.6	4
131	RBS/Channeling Analysis of Zinc Oxide Films Grown at Low Temperature by Atomic Layer Deposition. Acta Physica Polonica A, 2013, 123, 899-903.	0.5	4
132	Carbazole Derivative Based Near Ultraviolet Organic Light Emitting Diode with ZnMgO:Al Anode Layer. Solid State Phenomena, 0, 200, 45-49.	0.3	4
133	Electrical and structural characterization of nitrogen doped ZnO layers grown at low temperature by atomic layer deposition. Semiconductor Science and Technology, 2014, 29, 085006.	2.0	4
134	XRD and RBS studies of quasi-amorphous zinc oxide layers produced by Atomic Layer Deposition. Thin Solid Films, 2016, 612, 337-341.	1.8	4
135	Atomic layer deposition of ZnO:Al on PAA substrates. Journal of Physics: Conference Series, 2016, 764, 012004.	0.4	4
136	Tuning the properties of ALD-ZnO-based rectifying structures by thin dielectric film insertion – Modeling and experimental studies. Journal of Alloys and Compounds, 2017, 693, 1164-1173.	5.5	4
137	Valence band of ZnO:Yb probed by resonant photoemission spectroscopy. Materials Science in Semiconductor Processing, 2019, 91, 306-309.	4.0	4
138	Optical Response of Epitaxial ZnO Films Grown by Atomic Layer Deposition and Coimplanted with Dy and Yb. Physica Status Solidi (B): Basic Research, 2020, 257, 1900513.	1.5	4
139	ZnO Nanopowders by a Microwave Hydrothermal Method - Influence of the Precursor Type on Grain Sizes. Acta Physica Polonica A, 2011, 119, 683-685.	0.5	4
140	Extra-Low Temperature Growth of ZnO Thin Films by Atomic Layer Deposition. Journal of the Korean Physical Society, 2008, 53, 2880-2883.	0.7	4
141	From CdTe/Fe schottky barrier to Cd _{1-x} Fe _x Te semimagnetic semiconductor. Applied Surface Science, 1998, 123-124, 631-635.	6.1	3
142	Photoemission study of samarium on and CdTe(100). Applied Surface Science, 2002, 190, 356-360.	6.1	3
143	Growth conditions and structural properties as limiting factors of electrical parameters of ZnO thin films grown by Atomic Layer Deposition with diethylzinc and water precursors. Physica Status Solidi C: Current Topics in Solid State Physics, 2010, 7, 1550-1552.	0.8	3
144	Schottky contacts to ZnO layers grown by Atomic Layer Deposition: effects of H ₂ O ₂ functionalization and transport mechanisms. Applied Surface Science, 2021, 552, 149067.	6.1	3

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145	Cathodoluminescence Profiling for Checking Uniformity of ZnO and ZnCoO Thin Films. Acta Physica Polonica A, 2011, 119, 675-677.	0.5	3
146	X-ray Absorption Fine Structure Investigation of the Low Temperature Grown ZnCoO Films. Acta Physica Polonica A, 2012, 121, 883-887.	0.5	3
147	Electronic Band Structure of Cubic HgS. Acta Physica Polonica A, 1995, 87, 395-398.	0.5	3
148	4f Shell of Gd ²⁺ and Gd ³⁺ Ions in Sn _{1-x} Gd _x Te - Resonant Photoemission Study. Acta Physica Polonica A, 1997, 92, 875-878.	0.5	3
149	Electronic structure and magnetism in actinide compounds. Physica B: Condensed Matter, 2006, 378-380, 1033-1034.	2.7	2
150	Microscopic (AFM) and resonant photoemission study of Gd/Si(111) interface. Radiation Physics and Chemistry, 2009, 78, S22-S24.	2.8	2
151	PA-MBE Grown p-n (p-ZnO:(As+Sb)/i>n</i>-GaN) and p-i-n (p-ZnO:As/HfO ₂ /n-GaN) Heterojunctions as a Highly Selective UV Detectors. Key Engineering Materials, 2014, 605, 310-313.	0.4	2
152	Zn(Mn)O Surface Alloy Studied by Synchrotron Radiation Photoemission. Acta Physica Polonica A, 2005, 108, 689-696.	0.5	2
153	Cathodoluminescence Measurements at Liquid Helium Temperature of Poly- and Monocrystalline ZnO Films. Acta Physica Polonica A, 2011, 120, A-28-A-30.	0.5	2
154	Reflectivity Study of Hg _{1-x} CoxSe Crystals. Acta Physica Polonica A, 1994, 86, 875-878.	0.5	2
155	Contribution of Mn 3d Electrons To the Valence Band of Sn _{0.9} Mn _{0.1} Te. Acta Physica Polonica A, 1998, 94, 454-458.	0.5	2
156	Low-Temperature Cathodoluminescence of Nitrogen-Doped ZnO Films Deposited at Low-Temperature by Atomic Layer Deposition. Acta Physica Polonica A, 2022, 141, 135-139.	0.5	2
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